CA Series Roundness&Cylindricity Measurement Machine

Air float column

Accuracy ±0.0125µm Imported circular grating

High precision without wear out

Light measuring force and high precision

Each circle collect 14400points

















Measurement Functions

It can measure the roundness (column), straightness, runout, full runout, taper, diameter, concentricity, coaxiality, flatness, parallelism, perpendicularity, eccentricity, etc. of various regular and irregular ring-shaped workpieces

Surface waviness (Wc, Wp, Wv, Wt, Wa, Wq), spectrum analysis, and wave height analysis can be done.

Data Analysis and Processing

Spectrum analysis: analyze the amplitude of different frequency components

Abnormal data rejection: manual or automatic rejection of abnormal data, such as burrs, holes and bumps, etc. File management: automatic database saving of measurement data

Result printing: can be printed routinely or exported as PDF file

Item		Product Model		
		CA30	CA65	CA95
F Measure range	Parts max turn diame	ter ¢320mm	φ420mm	ф420mm
	Max measure height	300mm	400mm	500mm
	Max measure depth	Standard probe: 100mm(aperture < 36mm); Non-standard bracket can measure up to 30		
	Max load	25Kg	50Kg	100Kg
Air float main axis	Axial error	± (0.025+0.0005H/) μm 🔆	± (0.015+0.0003H) μm	± (0.0125+0.0003H) μm
	Radial error	± (0.025+0.0006X) µm 🔆	± (0.0125+0.0004X) μm	± (0.02+0.0004X) μm
Worktable	Table diameter	φ150mm	ф200mm	ф200mm
	e Adjust range	Adjust the eccentricity ±3mm; adjust the level ±1°		
	Straightness	0.5µm/100mm	0.4µm/100mm	
Parallelism between rotation axis and Z-axis guide		1.5µm/300mm	2µm/400mm	2.5µm/500mm
Horizontal travel		250mm		270mm
Sensor	Measuring range	500µm (radius differential)		
	Stylus form	2mm ruby probe (1mm, 0.5mm stylus available)		

The above table parameters are the default configuration, if you need other configurations can be optional according to the order.

Roundness Filter

1-500、1-150 1-50、1-15、15-500

Waviness Filter

3-16、17-100

Roundness Eva

Minimum area method, least squares method Minimum external circle method, maximum internal tangent circle method

Technical Parameters

※ H: measuring height from table. X: measuring radius.